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THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: SHIBUYA et al. Docket: 372106-102 (337559)
Serial No. 10/616,731 Examiner: Moore, Margaret G.
Filed: July 10, 2003 Art Unit: 1712
For: SILICA-BASED ORGANIC FILM AND METHOD OF MANUFACTURING THE SAME, AND
BASE MATERIAL COMPRISING ORGANIC FILM

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**TRANSMITTAL FOR SUPPLEMENTAL INFORMATION DISCLOSURE
STATEMENT**

Enclosed for filing in the above-identified application is:

- Supplemental Information Disclosure Statement;
- Supplemental Form PTO-1449; and
- A postcard as return receipt of the above-listed items.

The Commissioner is authorized to charge any required fees, or credit any overpayment to
Deposit Account Number 50-2778.

Respectfully submitted,


Ben Bedi
Reg. No. 39,904

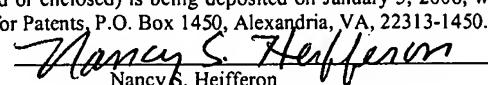
Dated: January 5, 2006

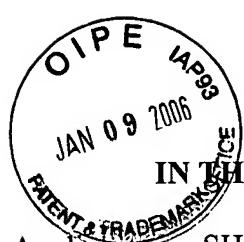
DECHERT LLP
Customer No. 37509

CERTIFICATE OF MAILING (37 CFR 1.8(a))

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited on January 5, 2006, with the U.S. Postal Service as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA, 22313-1450.

Date: January 5, 2006


Nancy S. Heifferon



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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Applicant submits herewith the references listed on the attached form PTO-1449 of which Applicant is aware and in respect of which there may be a duty to disclose in accordance with 37 CFR 1.56.

The filing of this information disclosure statement shall not be construed as a representation that a search has been made (37 CFR 1.97(g)), nor as an admission that the information cited is, or is considered to be, material to patentability, nor an admission that no other material information exists.

The filing of this information disclosure statement shall not be construed as an admission against interest in any manner.

Respectfully submitted,



Ben Bedi
Reg. No. 39,904

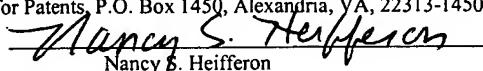
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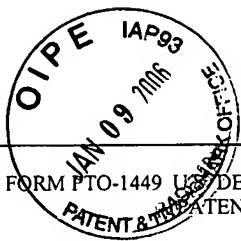
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Nancy S. Heifferon



FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT & TRADEMARK OFFICE		ATTY DOCKET NO.	SERIAL NO.
		372106-102 (337559)	10/616,731
SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT		APPLICANT	
		SHIBUYA et al.	
		FILING DATE	GROUP
		July 10, 2003	1712

U.S. PATENT DOCUMENTS							
EXAMINER INITIALS	Cite No.	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE
	AA	6,589,644	07/08/2003	Yamada et al.	428/312.6		

FOREIGN PATENT DOCUMENTS				
		FOREIGN PATENT DOCUMENT (inc. Country Code, Number, Kind Code)	PUBLICATION DATE	APPLICANT OR PATENTEE
	AB	JP 2000-77399 A	03/14/2000	Katayama et al
	AC	JP 2000-077399 (translation)	03/14/2000	Katayama et al

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)			

EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant	